

Serial No. 10/063,094

RD-27,190-3

1762

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Barry Lee-Mean Yang et al.

: Group Art Unit:

Serial No.: 10/063,094

: Examiner:

Filed: 3/19/02

: Paper No.:

For: APPARATUS AND METHOD FOR LARGE AREA CHEMICAL VAPOR DEPOSITION USING MULTIPLE EXPANDING THERMAL PLASMA GENERATORS

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APR 8 - 2002
TC 1700

PRELIMINARY AMENDMENT

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APR 05 2002

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Assistant Director of Patents and Trademarks
United States Patent and Trademark Office
Washington, DC 20231

Sir:

Please amend the Divisional Application, submitted herewith, of Application Serial No. 09/681,820, filed June 11, 2001, as follows.

If any additional fees for the accompanying response are required, Applicants request that this be considered a petition therefor. The Director is hereby authorized to charge any fees that may be required to Deposit Account 07-0868.

In the Specification:

On page 1, line 2, please insert the following: